



Docket No. FIS920010024US1

#7/Electron
4/26/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

B. Jagannath, et al.

Serial No.: 09/843,783

Filed: April 30, 2001

Group Art Unit: 2812

Examiner: Coleman

For: **A METHOD TO INCREASE CARBON AND BORON DOPING
CONCENTRATIONS IN Si AND SiGe FILMS**

Assistant Commissioner of Patents
Washington, D.C. 20231

TECHNOLOGY CENTER 2800

APR 18 2002

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RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement via telephone, applicants provisionally elect Group I, claims 1-9 and 15 without traverse.

Please charge any deficiencies or credit any overpayments to attorney's deposit account number 23-1951.

Respectfully submitted,

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